



UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: HIMI et al.

Serial No.: 10/716,606

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Title: METHOD FOR MANUFACTURING
SEMICONDUCTOR SUBSTRATE

Atty. Dkt.: 01-100-DIV

Art Unit: 2813

Examiner: Thanhha S. PHAM

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany St.
Alexandria, VA 22314

Date: 16 March 2006

AMENDMENT UNDER 37 CFR 1.111

Sir:

In response to the office action mailed 29 November 2005, please amend the application
as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of
this paper.

Remarks begin on page 8 of this paper.

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